



FOR IMMEDIATE RELEASE

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Per Wafer Data Logging Implemented on SSEC Single Wafer Wet Processors

Horsham, PA—SSEC 3300 wet cleaners and processors now provide full data logging capability on a per wafer basis. The operator has complete control of variables logged and definition of logging time cycles. Tracked variables include temperature, flow and concentration, spin speed, endpoint as determined by SSEC's exclusive WaferChek™ in-situ monitoring system, and more. All data is exportable in formats compatible with popular spreadsheet and quality management software.

Solid State Equipment Corporation manufactures a full line of wet cleaners and processors for wafers, photomasks, and flat panel displays at its headquarters in suburban Philadelphia. These systems implement single wafer technology, allowing high precision processing at production volumes, all at the lowest cost of ownership. SSEC has been developing and manufacturing technology solutions for semiconductor processing for over 40 years.

SSEC maintains sales and service officers worldwide, and customer support and process development centers in Horsham, Pennsylvania, Regensburg, Germany, Newcastle, England, Taiwan, R.O.C., Shanghai, P.R.C., and Woodlands, Singapore. For further information, contact Rich Richardson at SSEC, 215-328-0700, FAX 267-965-2841, or info@ssecusa.com, or visit www.ssecusa.com.

Table with 11 columns: Wafer, Start, Finish, Duration, SpinMod1, SpinMod2, SpinMod3, SpinMod4, SpinMod5, SpinMod6, and a detailed log of processing steps. Includes summary rows for total time and average output.